

In re Application of:

Pan et al.

Serial No.: 08/682,935

Filed: July 16, 1996

For: TECHNIQUE FOR ELIMINATION OF PITTING ON SILICON SUBSTRATE

DURING GATE STACK ETCH

Examiner: H. Nguyen

Group Art Unit: 2812

Attorney Docket No.: 2915US(96-0149)

NOTICE OF EXPRESS MAILING

Express Mail Mailing Label Number 548957369US

Date of Deposit with USPS: May 6, 1998 Person mailing Deposit: Timothy W. Ricks

PRELIMINARY AMENDMENT

Assistant Commissioner for Patents Washington, D.C. 20231

Sir:

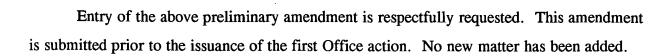
Prior to examination of the claims on the merits in the above-identified application, please amend this application as follows:

IN THE CLAIMS:

Please cancel claims 1-22.

REMARKS

No new subject matter has been introduced with these amendments.



Respectfully submitted,

Robert G. Winkle

Registration No. 37,474

Attorney for Applicants

TRASK, BRITT & ROSSA

P. O. Box 2550

Salt Lake City, Utah 84110-2550

Telephone: (801) 532-1922

Date: May 6, 1998

RGW/cw

N:\2269\2915\prelim.amd